

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
)
Tsuyoshi MATSUMURA et al.)
) Group Art Unit: Not yet assigned
Serial No.: Not Yet Assigned)
) Examiner: Not yet assigned
Filed: October 27, 2003)
)
For: INSULATING TUBE,)
SEMICONDUCTOR DEVICE)
EMPLOYING THE TUBE, AND)
METHOD OF)
MANUFACTURING THE SAME)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

INFORMATION DISCLOSURE STATEMENT UNDER 37 C.F.R. § 1.97(b)

Pursuant to 37 C.F.R. §§1.56 and 1.97(b), applicants bring to the Examiner's attention the document listed on attached Form PTO-1449. A copy of the listed document is attached. Applicants respectfully request that the Examiner consider the document listed on attached Form PTO-1449 and indicate it was considered by making an appropriate notation on this form.

This Information Disclosure Statement is being filed with the above-referenced application.

The following is listed on the accompanying PTO-1449 and is in a non-English language. An English language abstract is attached.

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1. Japanese Patent (Laid-Open) No. 03-156929 - This document discloses a method of making semiconductor devices, comprising the steps of forming holes in an inter-layer dielectric film to decrease permittivity between wires, forming an inter-layer dielectric film by oxidation of deposited polysilicon film, and implanting oxygen ions in inter-layer dielectric film.

This submission does not represent that a search has been made or that no better art exists and does not constitute an admission that the listed document is material or constitutes "prior art." If the Examiner applies the document as prior art against any claim in the application and applicants determine that the cited document does not constitute "prior art" under United States law, applicants reserve the right to present to the office the relevant facts and law regarding the appropriate status of such document. Applicants further reserve the right to take appropriate action to establish the patentability of the disclosed invention over the listed document, should the document be applied against the claims of the present application.

If there is any fee due in connection with the filing of this Statement, please charge the fee to our Deposit Account No. 06-0916.

Respectfully submitted,

FINNEGAN, HENDERSON, FARABOW,
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Dated: October 27, 2003

Enclosures
RVB/FPD/cma

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INFORMATION DISCLOSURE CITATION

Atty. Docket No.	03180.00339	Serial No.	TBA
Applicant	Tsuyoshi MATSUMURA et al.		
Filing Date	10/27/03	Group:	

U.S. PATENT DOCUMENTS							
Examiner Initial*		Document Number	Issue Date	Name	Class	Sub Class	Filing Date If Appropriate

FOREIGN PATENT DOCUMENTS							
		Document Number	Publication Date	Country	Class	Sub Class	Translation Yes or No
		03-156929	July 4, 1991	Japan			Abstract

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)	

Examiner	Date Considered
*Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	
Form PTO 1449	Patent and Trademark Office - U.S. Department of Commerce